INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 9, 2026	
IGI Report Number	LG837616854
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MIXED CUT
Measurements	8.96 X 5.87 X 3.96 MM

GRADING RESULTS

Carat Weight	2.15 CARATS
Color Grade	F
Clarity Grade	FLAWLESS

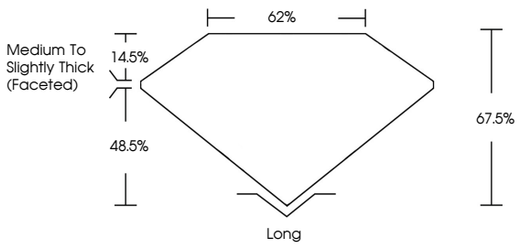
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG837616854

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG837616854
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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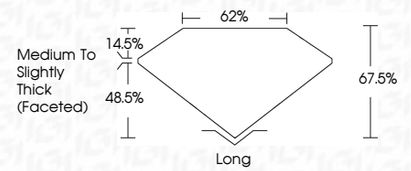
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IGI

September 9, 2026
IGI Report No LG837616854
CUSHION MIXED CUT
8.96 X 5.87 X 3.96 MM
Carat Weight 2.15 CARATS
Color Grade F
Clarity Grade FLAWLESS
Depth 67.5%
Table 62%
Girdle Medium To Slightly Thick (Faceted)
Culet Long
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG837616854
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Type IIa